

Application Serial No. 10/738,398  
Reply to Office Action of September 29, 2005

NOV 30 2005

PATENT  
Docket: CU-3402

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application: Yi Sun CHUNG

Serial No: 10/738,398

Filed: December 17, 2003

For: METHOD FOR FORMING METAL-INSULATOR-METAL CAPACITOR OF  
SEMICONDUCTOR DEVICE

] GRP ART UNIT: 2891

] Ex.: Wilson, Christian D.

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]

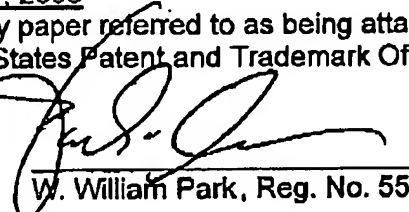
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CDW 12/7/05

**Certification under 37 C.F.R. §1.8(a)**

The USPTO Central Fax No. (571) 273-8300

Date of Fax Transmittal: November 30, 2005

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.

  
W. William Park, Reg. No. 55,523**AMENDMENT AFTER FINAL UNDER 37 CFR 1.116****MAIL STOP AF**

The Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Sir:

In response to the office action dated September 29, 2005, setting a 3-month shortened statutory period for a reply ending on December 29, 2005, the applicant submits the following responsive amendment in the above-identified application. This amendment is considered to place the application in better condition for allowance.

No fee is believed to be required with this amendment, but, if this is not the case, please charge the requisite fee (or credit any overpayment) to Deposit Account No. 12-0400.